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U.S. PATENT DOCUMENTS (not submitted for applications filed after 6/30/03)							
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FOREIGN PATENT DOCUMENTS							
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
	09-035927	02-1997	Japan			Abstract	
	2001-053487	02-2001	Japan			Abstract	
	09-115708	05-1997	Japan			Abstract	
	2001-308574	11-2001	Japan			Abstract	
	2003-115692	04-2003	Japan			Abstract	
	11-354972	12-1999	Japan			Abstract	
	05-183285	07-1993	Japan			Abstract	
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
		Masaki ABE et al., "Application of Thin Ferrite Film and Ultra-Fine Particles formed in Aqueous Solution to Microwave/Nano-Biotechnology", p721-729, No. 6, Vol. 27, 2003; Journal of The Magnetics Society of Japan					
		International Search Report PCT/JP2004/002104 filed April 27, 2004					
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